

MEMS & Micro Devices

MEMS Foundry Floor plan

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Foundry facts

Legend

- 1 Wet processing
- 2 Lithography
- (3) Deposition & plasma etching
- (4) Thermal processing (ATM/LPCVD)
- 5 Measuring/inspection
- 6 Grinding & back-end processing

- 2650 m² state-of-the-art cleanroom of class 100 – 10,000
- Large set of 200mm state-ofthe-art tools
- Flexibility to work with materials ranging from Ag to Zn, including 'CMOS-forbidden' materials, alloys, dielectrics, and polymers like Parylene
- Flexibility to work with substrates: Si, III/V, glass; square and round; up to 8"

Detailed info on the foundry toolkit can be found on our website.

